

**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Naomasa SHIRAISHI

Application No.: Rule 53(b) Continuation of 08/423,457 filed April 19, 1995

Filed: October 6, 2003

Docket No.: 032136.09

For: PROJECTION EXPOSURE METHOD WITH LUMINOUS FLUX DISTRIBUTION  
(AS AMENDED)

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to initial examination on the merits, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**